



Practitioner's Docket No.: 791_075 DIV

Richard A. A'G/10/02
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Yukihiisa TAKEUCHI, Tsutomu NANATAKI,
Toshikazu HIROTA and Koji KIMURA

Ser. No.: 09/963,696

Art Unit: 2834

Filed: September 26, 2001

Examiner: Not Assigned

Confirmation No.: 2017

For: PIEZOELECTRIC/ELECTROSTRICTIVE DEVICE AND PRODUCTION
METHOD THEREOF

Assistant Commissioner for Patents
Washington DC 20231

I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail addressed to
Assistant Commissioner for Patents, Washington D.C. 20231
on November 7, 2001.

Tara L. Preston
Tara L. Preston

PRELIMINARY AMENDMENT

Sir:

Prior to examination of the above-identified application on the merits, please amend the
application as follows:

In the Claims:

Please add new claims 14-18 as follows:

14. (NEW) A method of fabricating a piezoelectric/electrostrictive device according to
claim 5, wherein said method includes a step of laminating on a surface constituting the
outermost layer of said ceramic green laminate having at least one hole, when laminating at
least a plurality of ceramic green sheets having at least a hole formed thereon, a ceramic green
sheet having at least one hole formed thereon which is mounted on a plastic film in such a
manner that said plastic film is placed as a new outermost layer, and removing said plastic
film after the holes are accurately aligned.